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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 Applicant: Chih-Ning Wu Examiner: Umez Eronini, Lynette T
 Filing Date: 07/16/2001 Art Unit: 1765
 App. No.: 09/682,054 Docket No.: NAUP0374USA

10 Title: EXTRUSION-FREE WET CLEANING PROCESS FOR COPPER-DUAL
 DAMASCENE STRUCTURES

 To: Commissioners for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

15 Subject: Response to the Office communication (Notice of Non-Compliant
 Amendment) dated 06/19/2003

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Dear Sir or Madame:

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INTRODUCTORY COMMENTS

 In reply to the Office communication identified above, a new version of
 AMENDMENT that complies with the guidelines of the voluntary revised amendment
 practice is respectfully submitted to replace the prior version AMENDMENT filed
30 06/12/2003. Entering of the new version AMENDMENT herein and consideration of all
 amendments are politely requested.